

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| In re Application |) | <u>PATENT APPLICATION</u> |
| |) | |
| Inventor(s): Cleeves et al. |) | |
| |) | Art Unit: 2814 |
| Application No.: 10/681,509 |) | |
| |) | Examiner: Howard Weiss |
| Filed: October 7, 2003 |) | |
| |) | Atty Docket No. SAND-01135US0 |
| Title: UNIFORM SEEDING TO |) | (formerly MA-108) |
| CONTROL GRAIN AND |) | |
| DEFECT DENSITY OF |) | <u>Customer No. 64948</u> |
| CRYSTALLIZED SILICON |) | |
| FOR USE IN SUB-MICRON |) | |
| THIN FILM TRANSISTORS) |) | |

RESPONSE TO OFFICE ACTION UNDER 37 C.F.R. § 1.111 TO ACCOMPANY REQUEST
FOR CONTINUED EXAMINATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

To the Commissioner:

Applicants request continued examination under 37 CFR 1.114. The amended claims and remarks included herein constitute the required submission.

Amendments to the claims begin on page 2 of this paper.

Remarks begin on Page 11 of this paper.